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**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER 1700**

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03500.103115

PATENT APPLICATION

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	:	Examiner: David G. Weisz
Satoru Nishiuma	)	
	:	Group Art Unit: 1797
Application No.: 10/553,870	)	
	:	Confirmation No.: 1107
Filed: October 21, 2005	)	
	:	
For: OPTICAL ANALYSIS DEVICE	)	June 11, 2009

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL REJECTION**

Sir:

In response to the Office Action mailed March 11, 2009, please amend the  
above-identified application as follows.